

In re Application of:  
Wada, et al.

Serial No.: 09/830,611

**Confirmation No.:**

Filed: April 30, 2001

**For:      Film Deposition Method  
              and Apparatus**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Group Art Unit: 1762

Examiner: Unknown

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**37 CFR 1.8**

I hereby certify that this correspondence is being deposited on 22 May, 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

22 May 02                      Cecilia B. Patten  
Date                                      Signature

## REVOCATION AND POWER OF ATTORNEY

The Assignee of the above captioned application, Applied Materials, Inc., hereby revokes the previously appointed power of attorney for this application.

Assignee hereby appoints the following attorneys/agents to prosecute this application and transact all business in the Patent & Trademark Office connected therewith:

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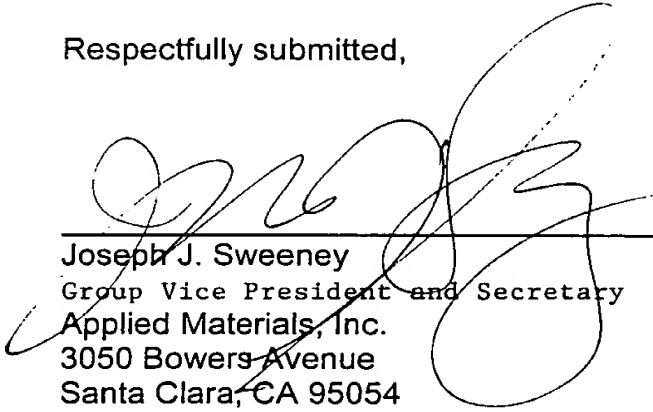
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and grant full powers to prosecute this application, to make alterations and amendments therein, to inspect and make copies thereof and of any papers in appellate and inter party proceedings in which it may be involved, and to transact all business in the United States Patent & Trademark Office connected therewith.

Respectfully submitted,



\_\_\_\_\_  
Joseph J. Sweeney  
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Date: May 1, 2002